

Search Notes**Application/Control No.**

10/606,779

Examiner

Paul D. Kim

Applicant(s)/Patent under Reexamination

IMAMURA, MASAO

Art Unit

3729

SEARCHED

Class	Subclass	Date	Examiner
29	592.1 595 606 841 847 858 885	10/26/2005	PK
250	231.13		
	231.14		
156	293 295 311		
216	22,39,41		
451	4,51	↓	

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Text Search EAST/NPL (IEEE)	10/26/2005	PK

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner